



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 7681
Akihisa HONGO et al. : Docket No. 2001_0519A
Serial No. 09/842,650 : Group Art Unit 1763
Filed April 27, 2001 : Examiner S. Macarthur

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TC 1700

REVOLUTION MEMBER SUPPORTING
APPARATUS AND SEMICONDUCTOR
SUBSTRATE PROCESSING APPARATUS

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of
August 1, 2003.

The fee of \$420.00 is

- ☒ submitted herewith.
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is
enclosed.
☐ Small entity status of this application is established by a Small Entity Status Assertion
which
☐ is enclosed.
☐ has been previously submitted.

Respectfully submitted,

Akihisa HONGO et al.

01/06/2004 CCHAU1 00000173 09842650

01 FC:1252

420.00 DP

By

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January 2, 2004